

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE CEIVED

In re Patent Application of	MAIL STOP AF	NOV / 8 2004
Tuqiang Ni et al.	Group Art Unit: 1763	TC 1700
Application No.: 09/788,365	Examiner: Rudy Zervigon	
Filed: February 21, 2001	Confirmation No.: 3359	Ð
For: GAS INJECTION SYSTEM FOR PLASMA PROCESSING		

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 3, 2004, please amend the above-identified patent application as follows: